

Fig. 1A

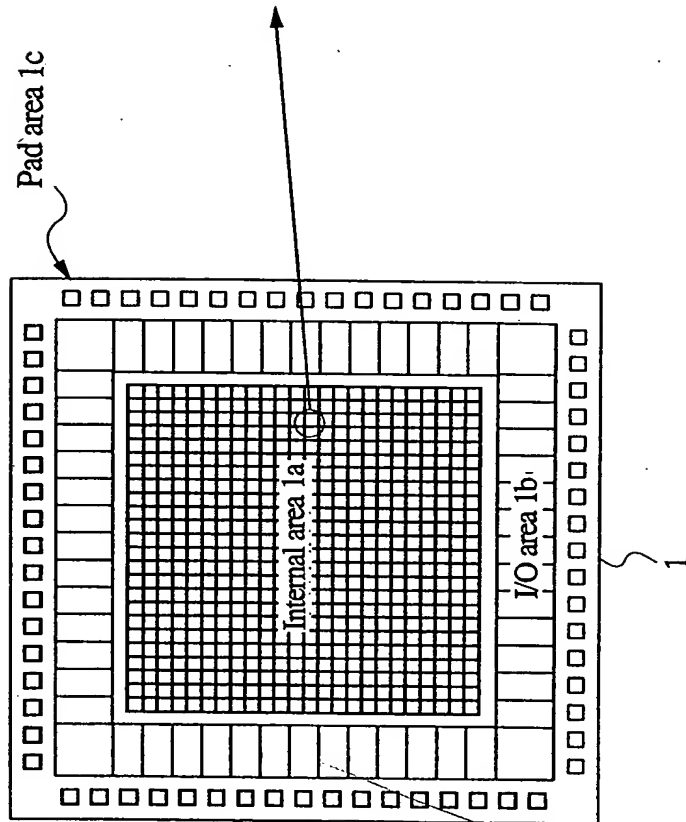


Fig. 1B

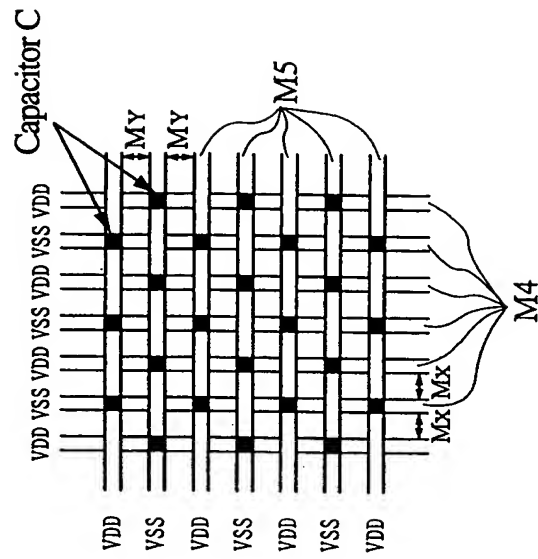


Fig. 2

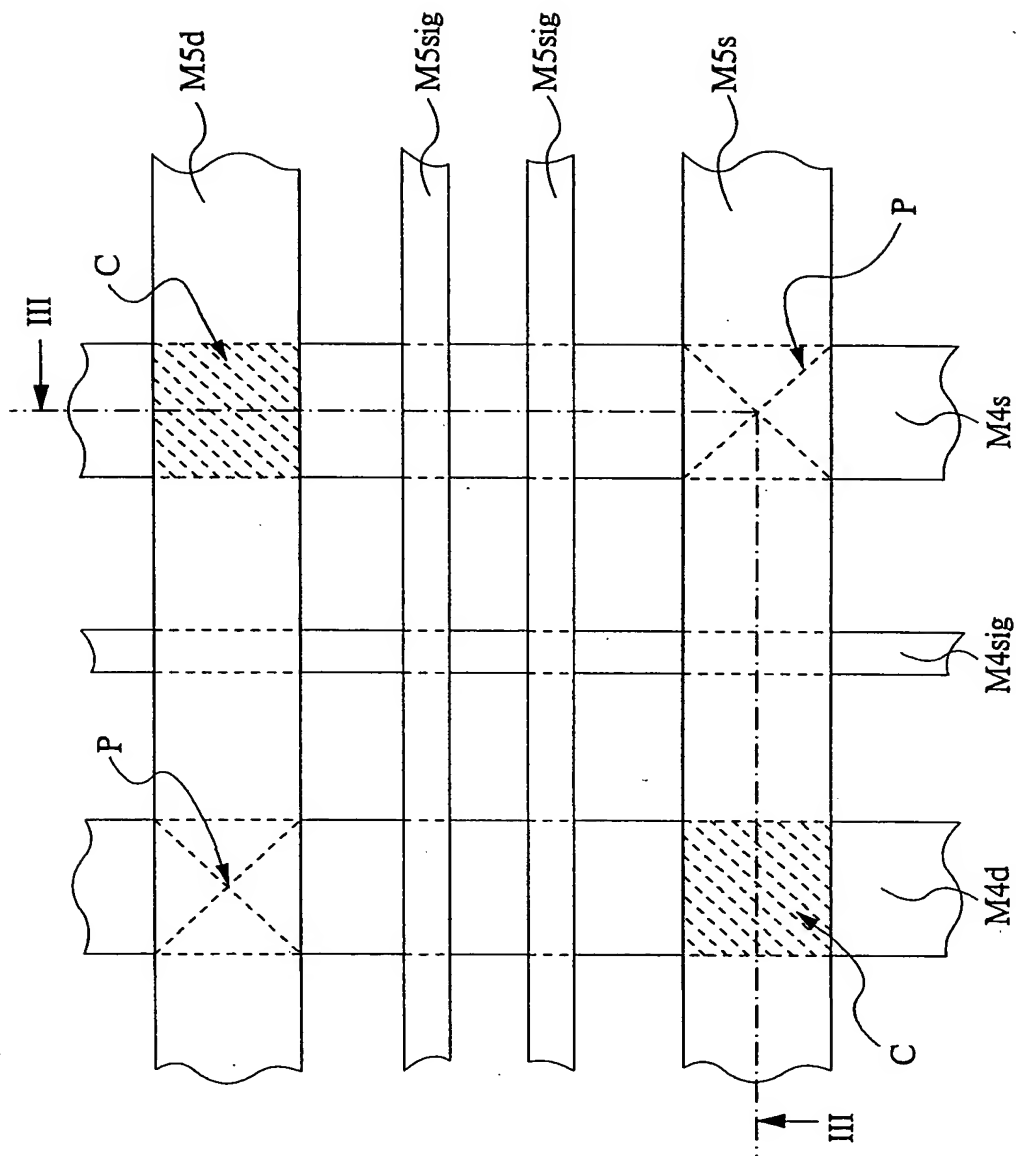


Fig. 3

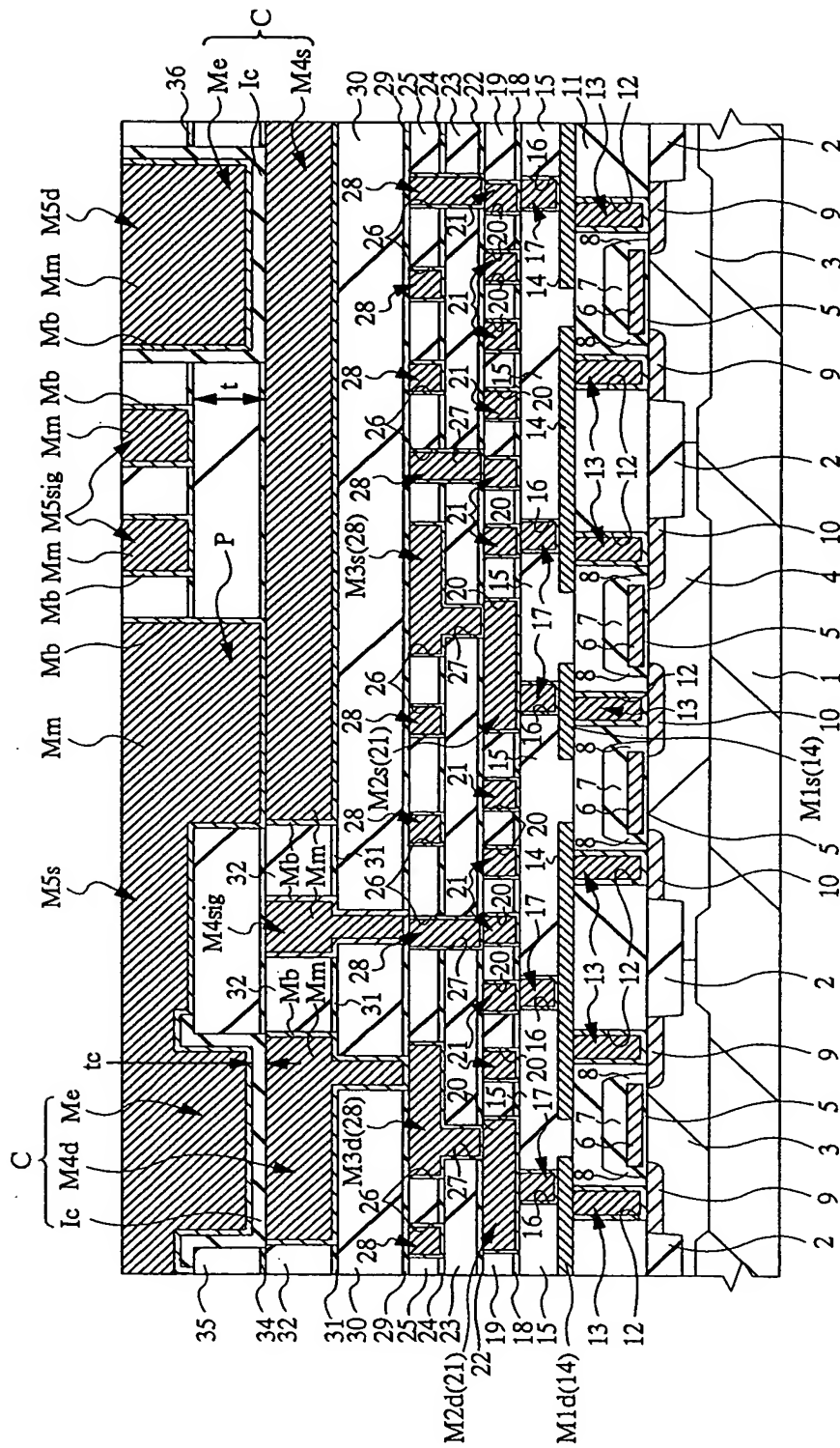


Fig. 4

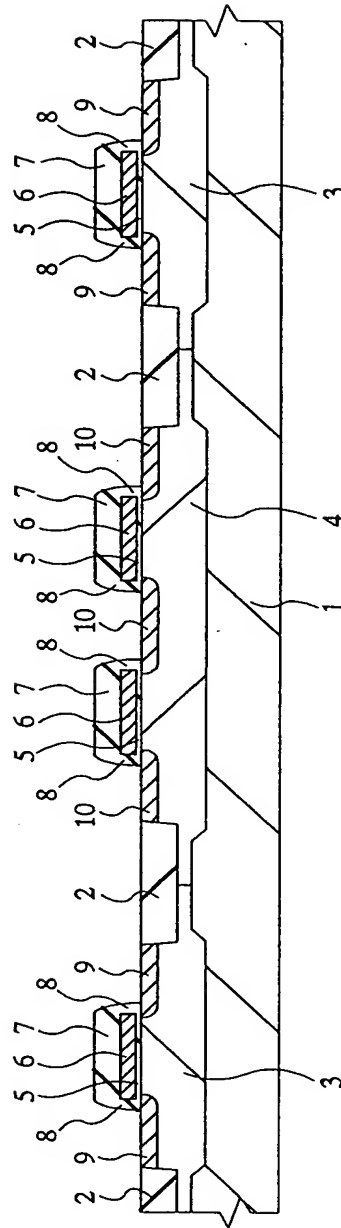


Fig. 5

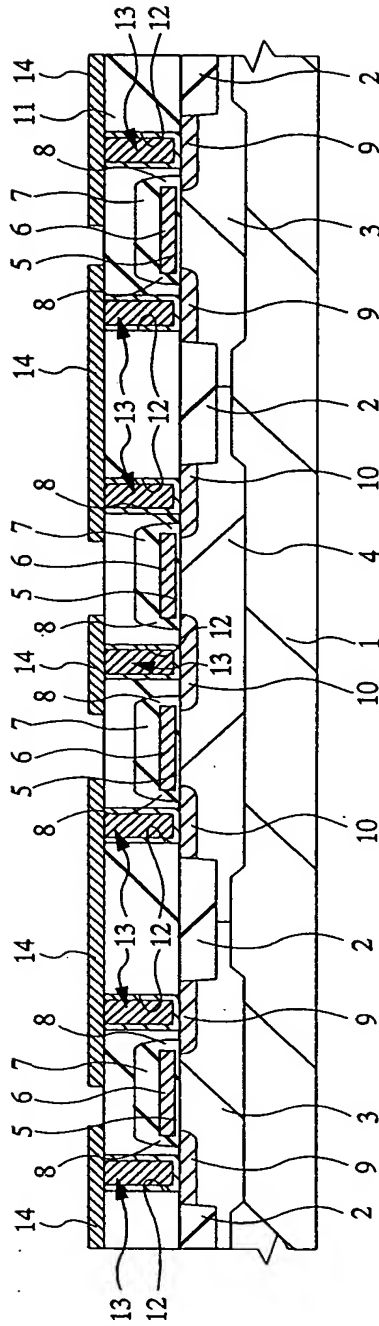


Fig. 6

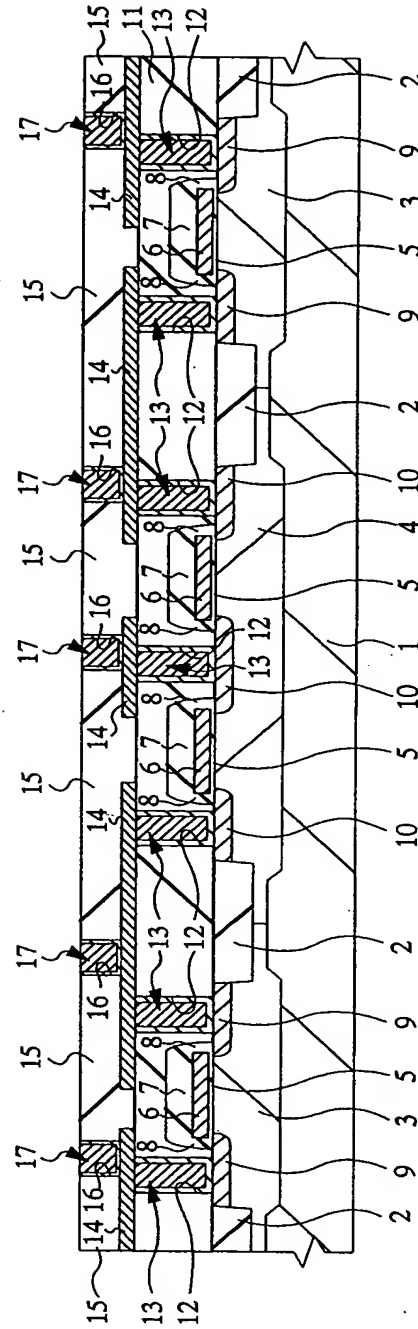


Fig. 8

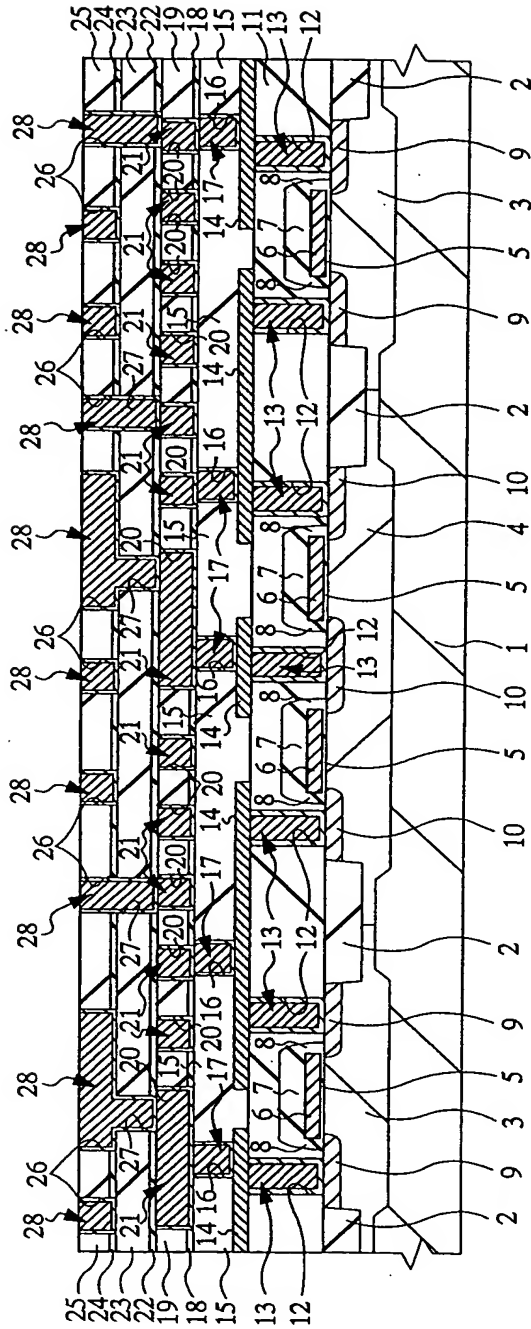


Fig. 9

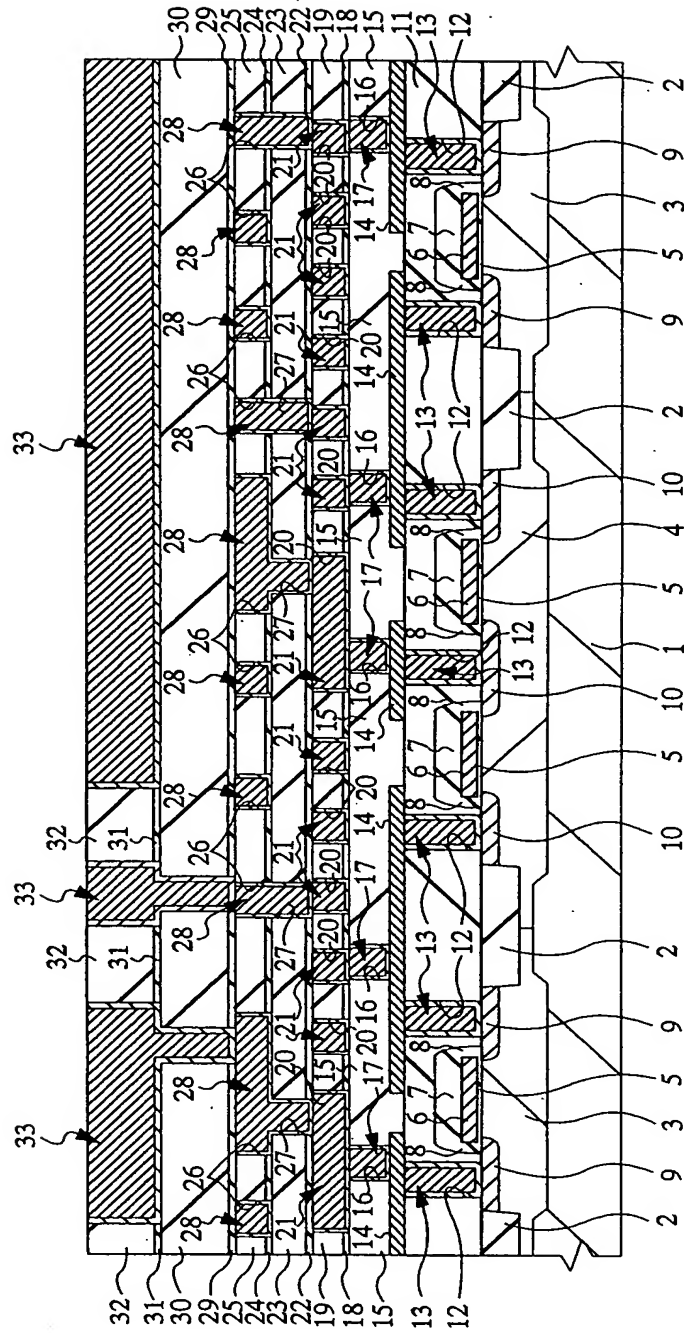


Fig. 10

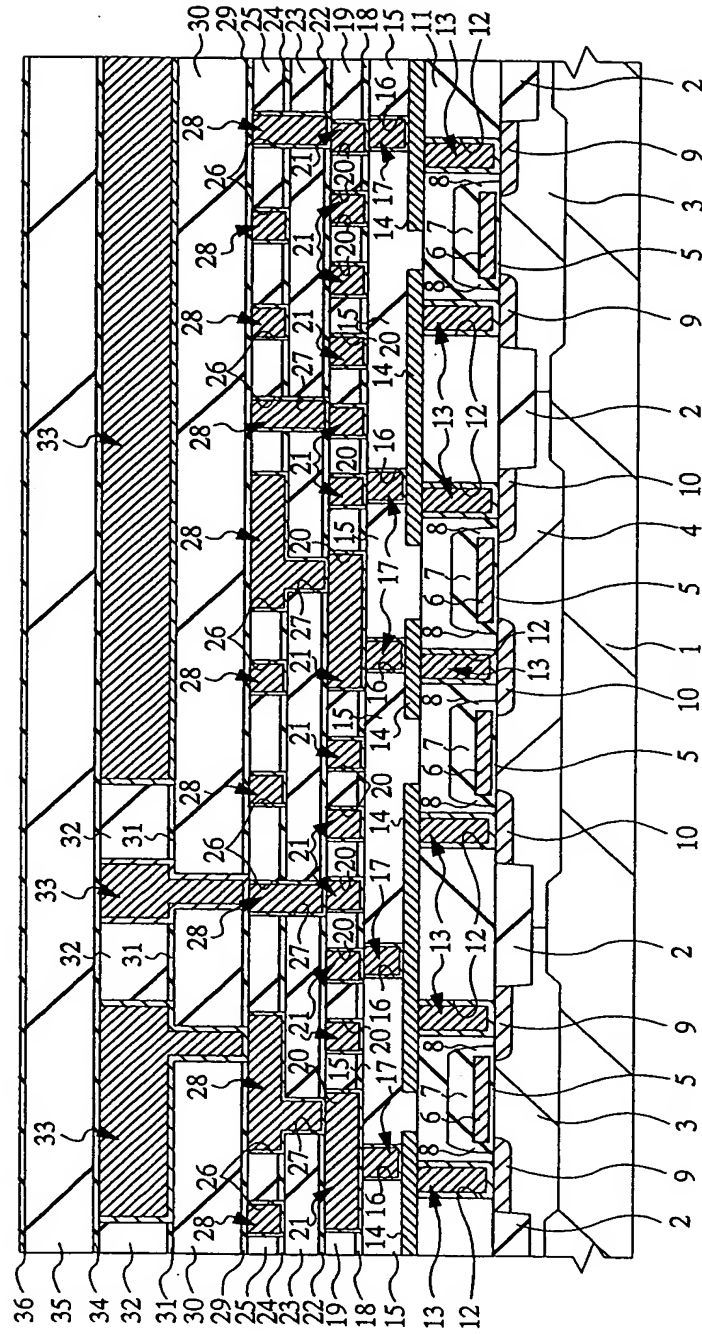


Fig. 11

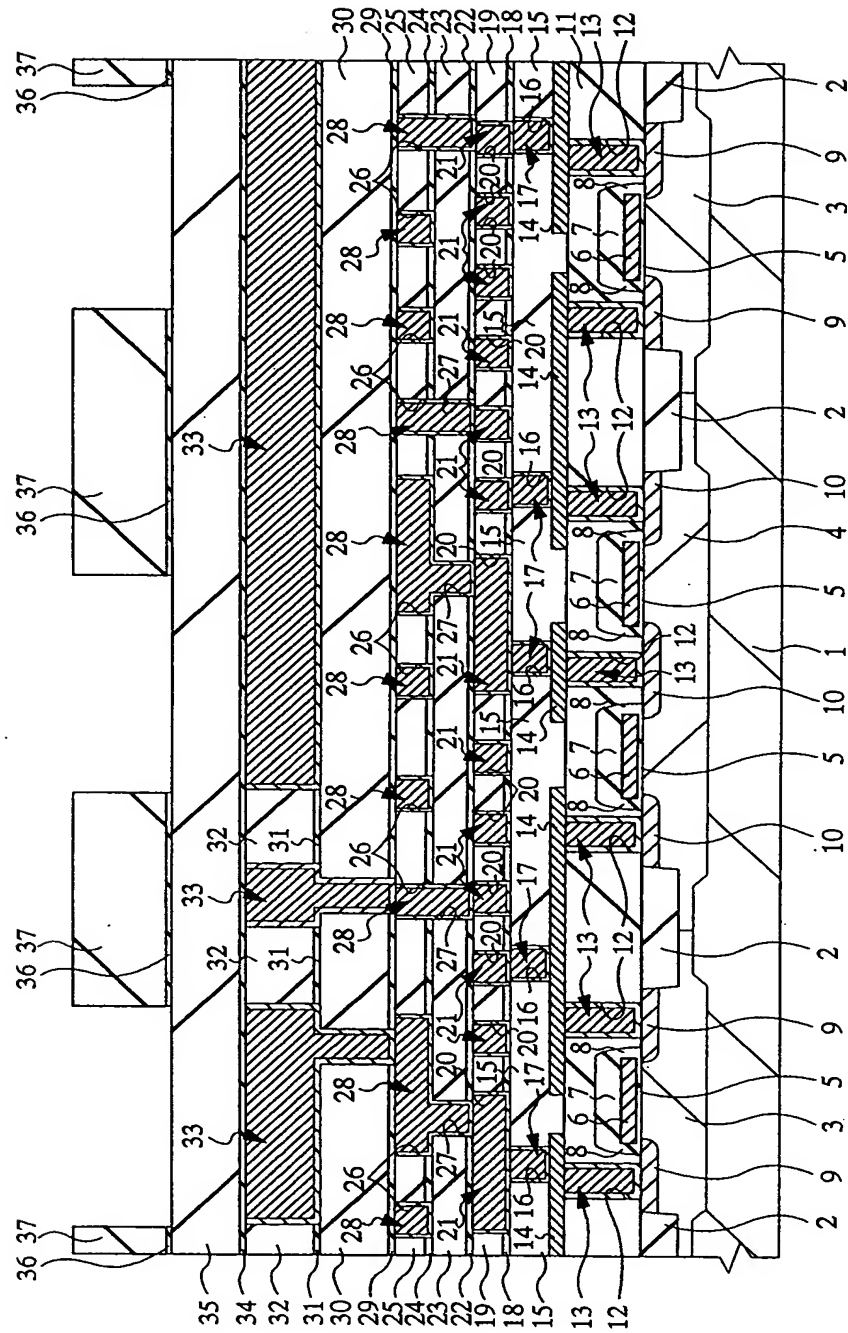


Fig. 12

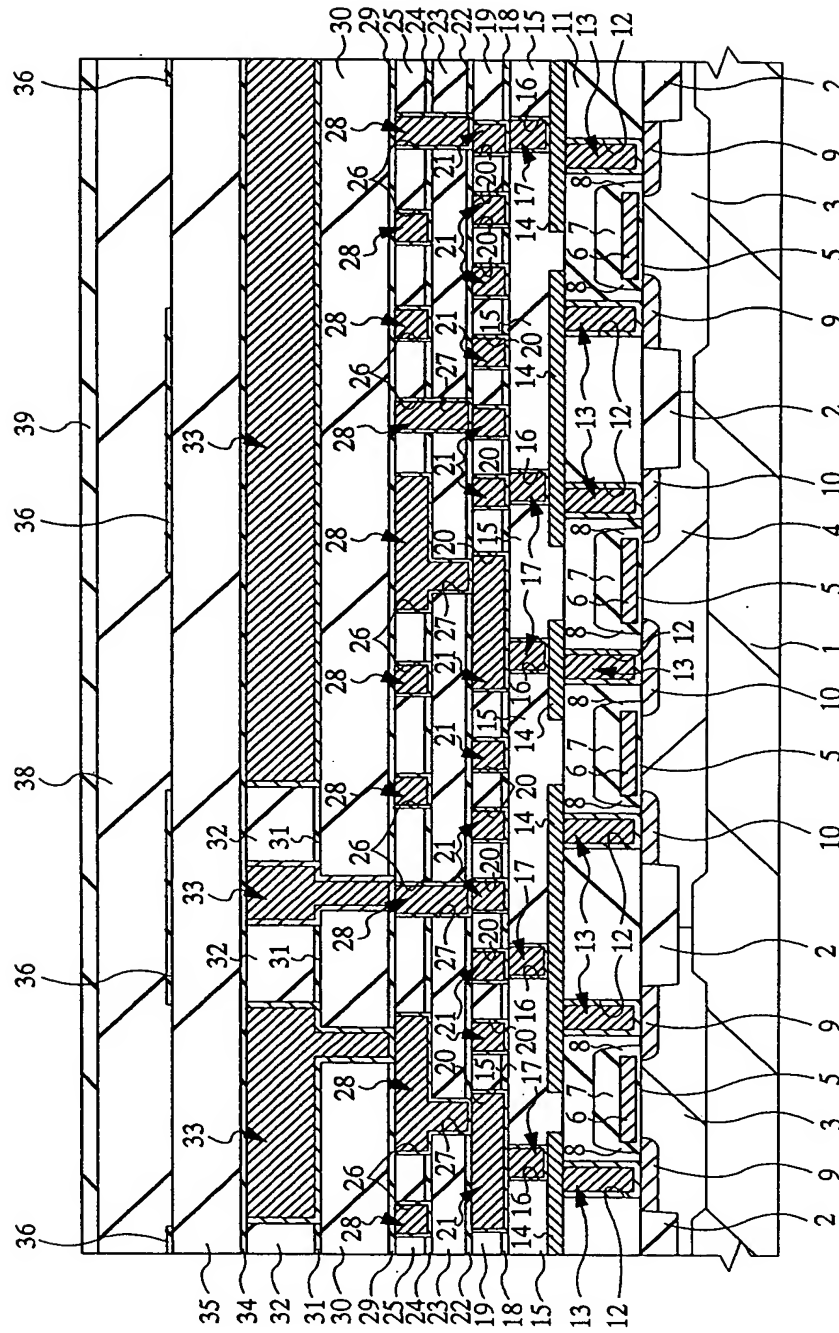


Fig. 13

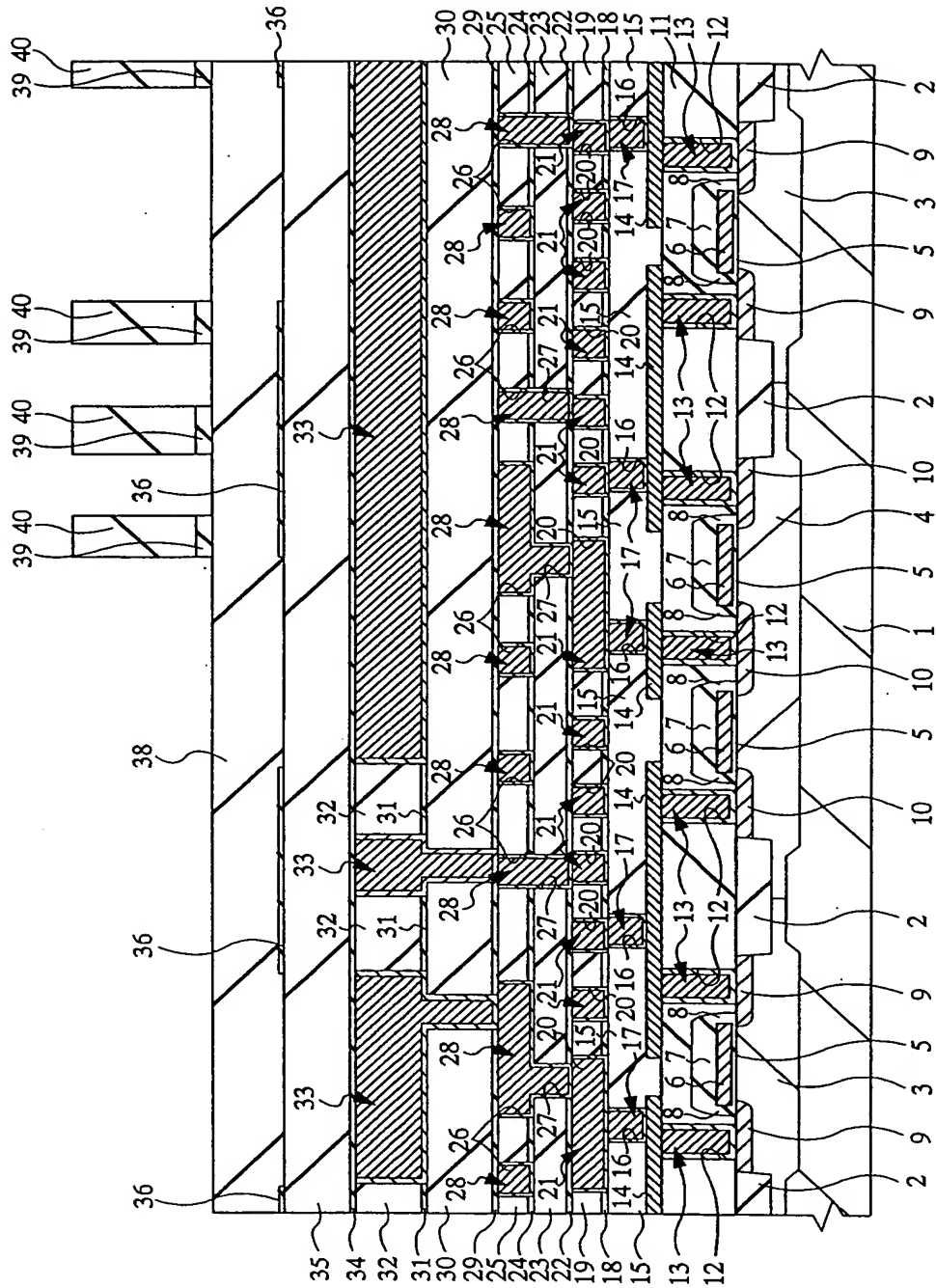


Fig. 14

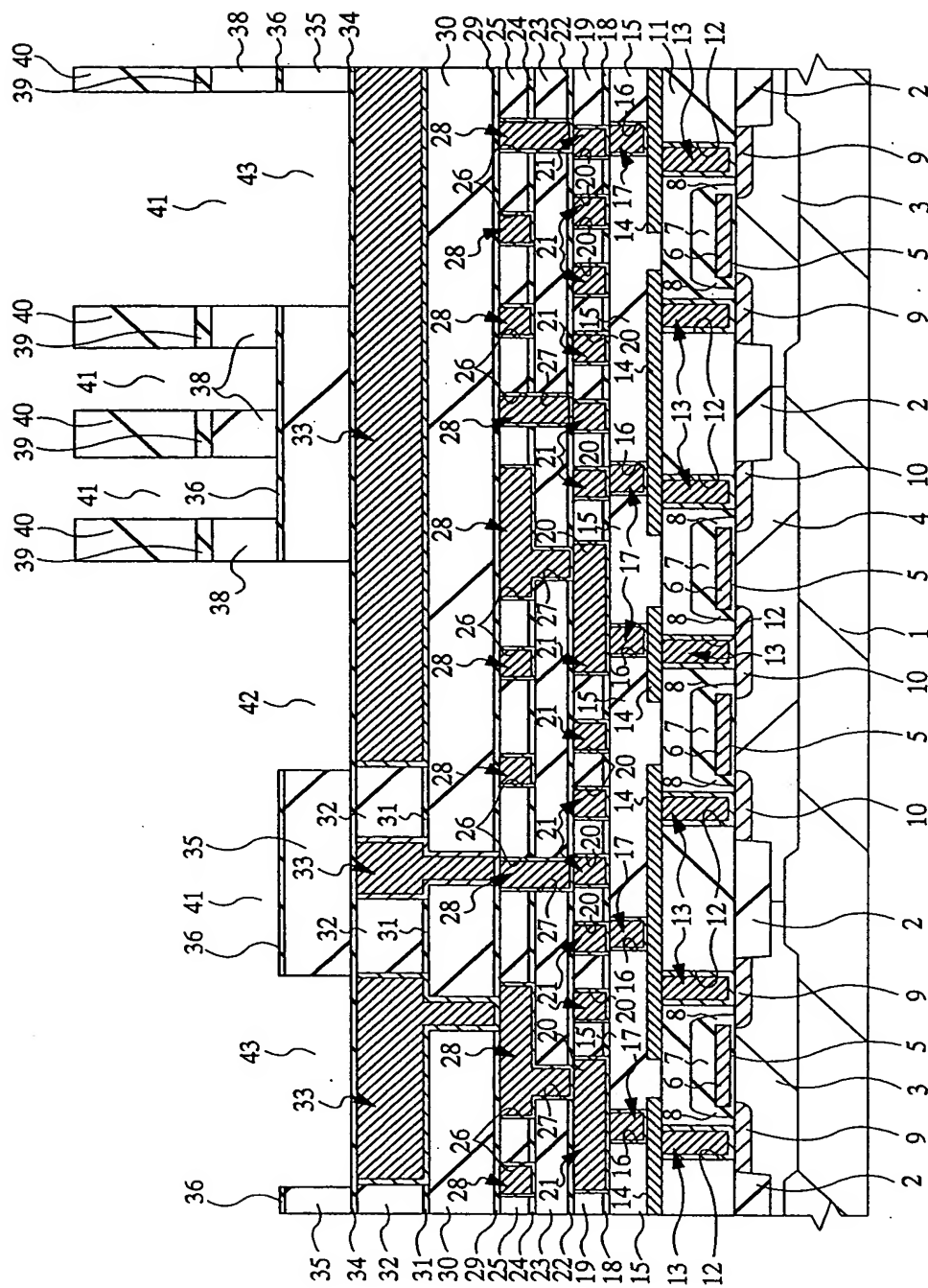


Fig. 15

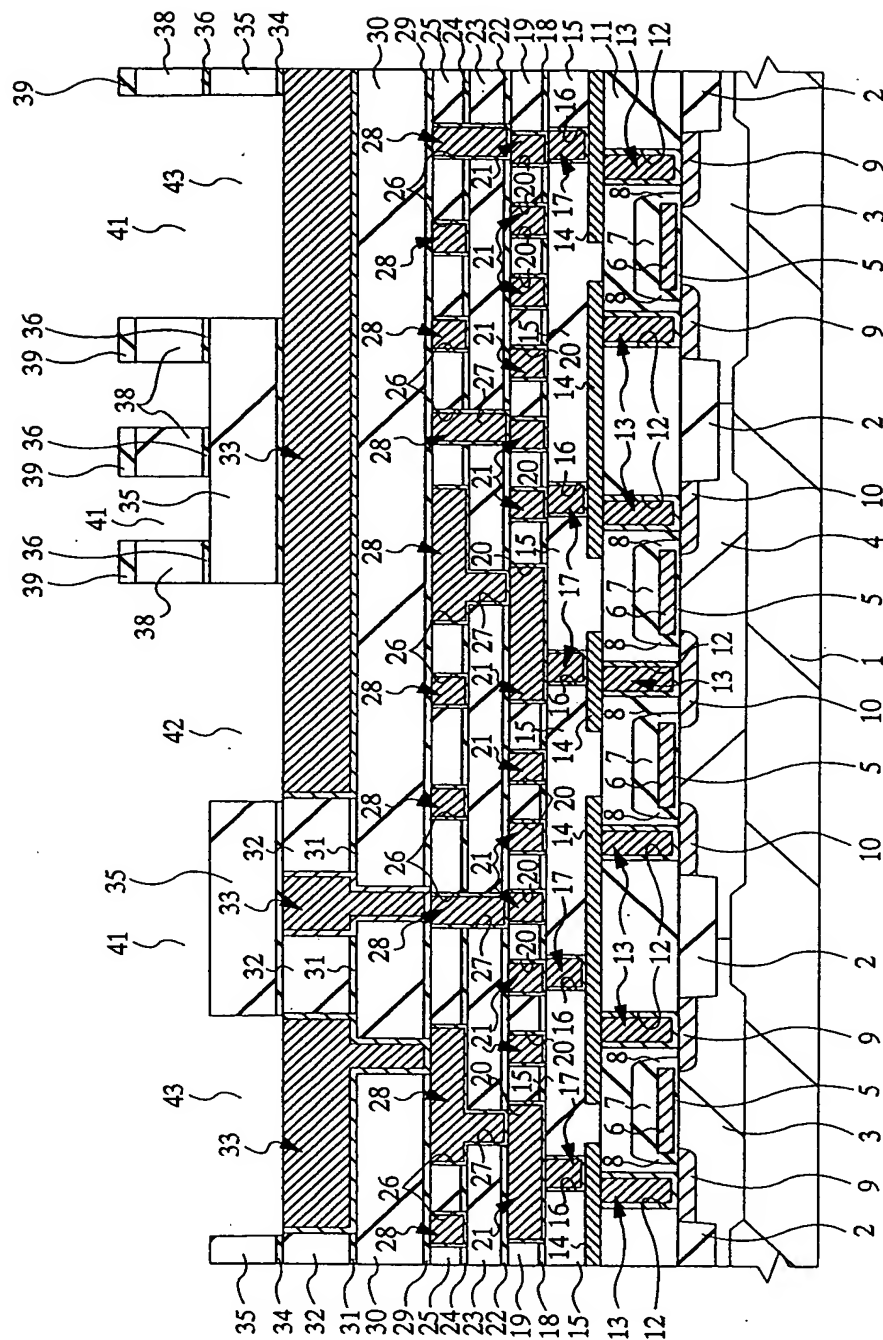


Fig. 16

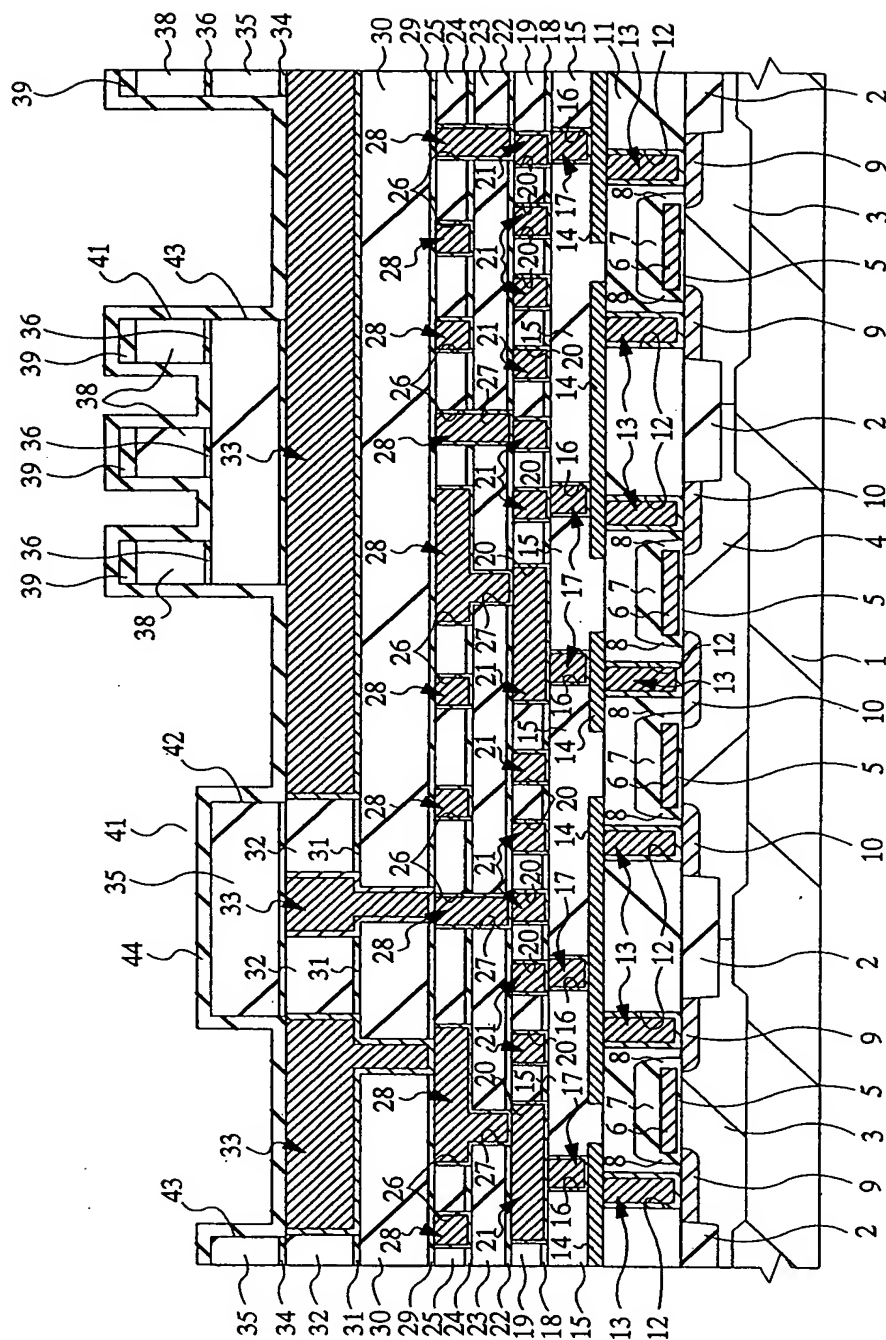


Fig. 17

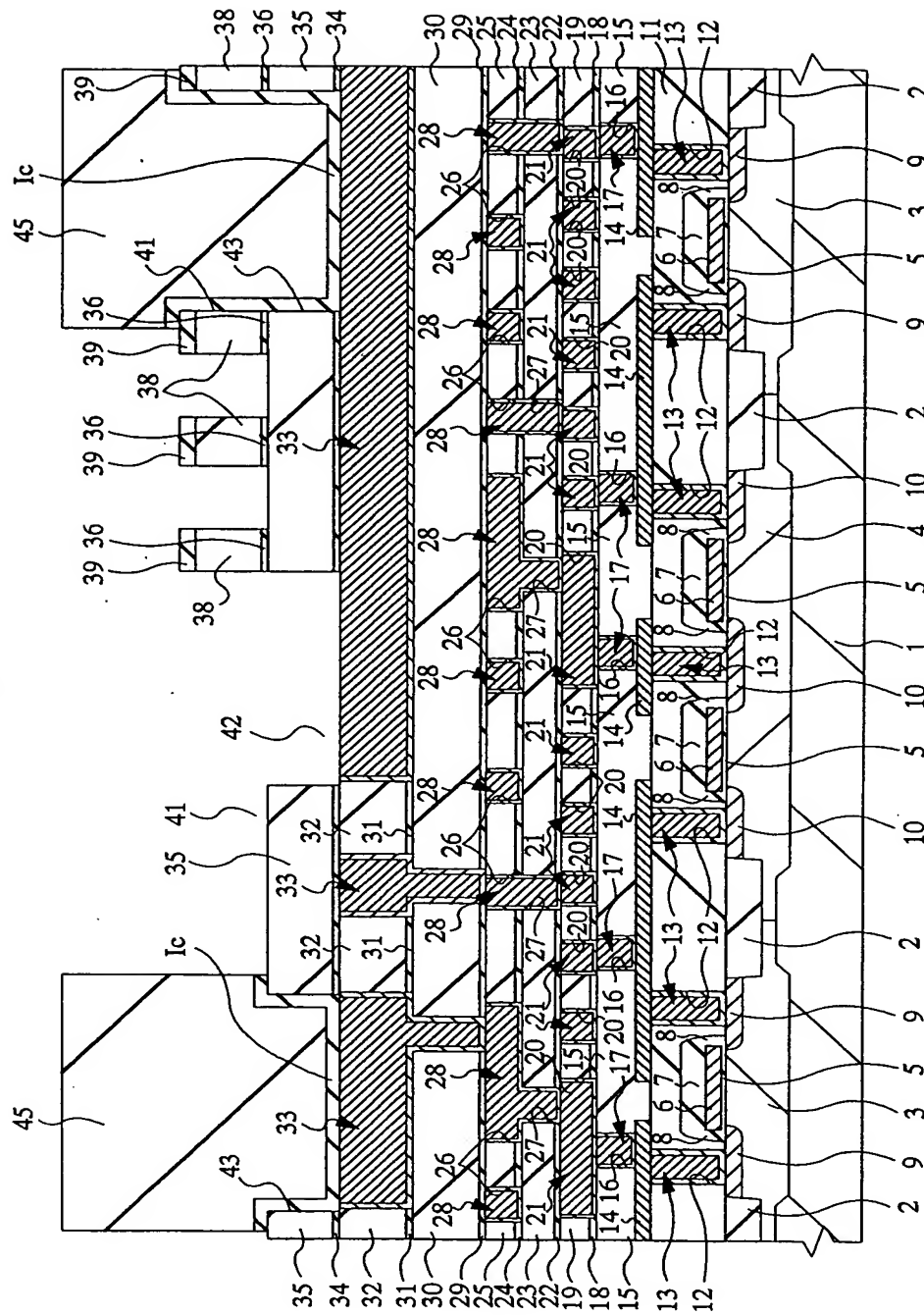


Fig. 18

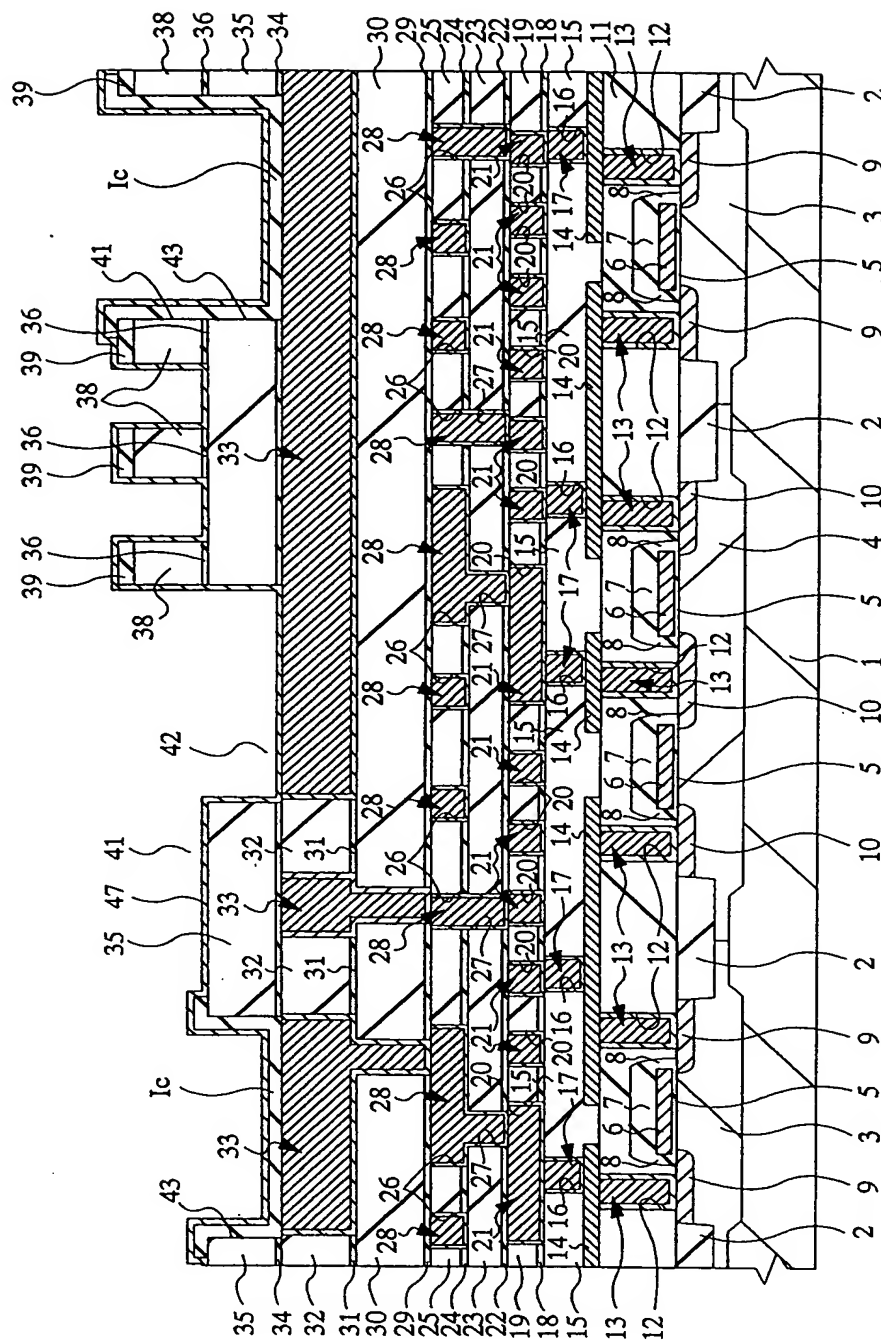


Fig. 19

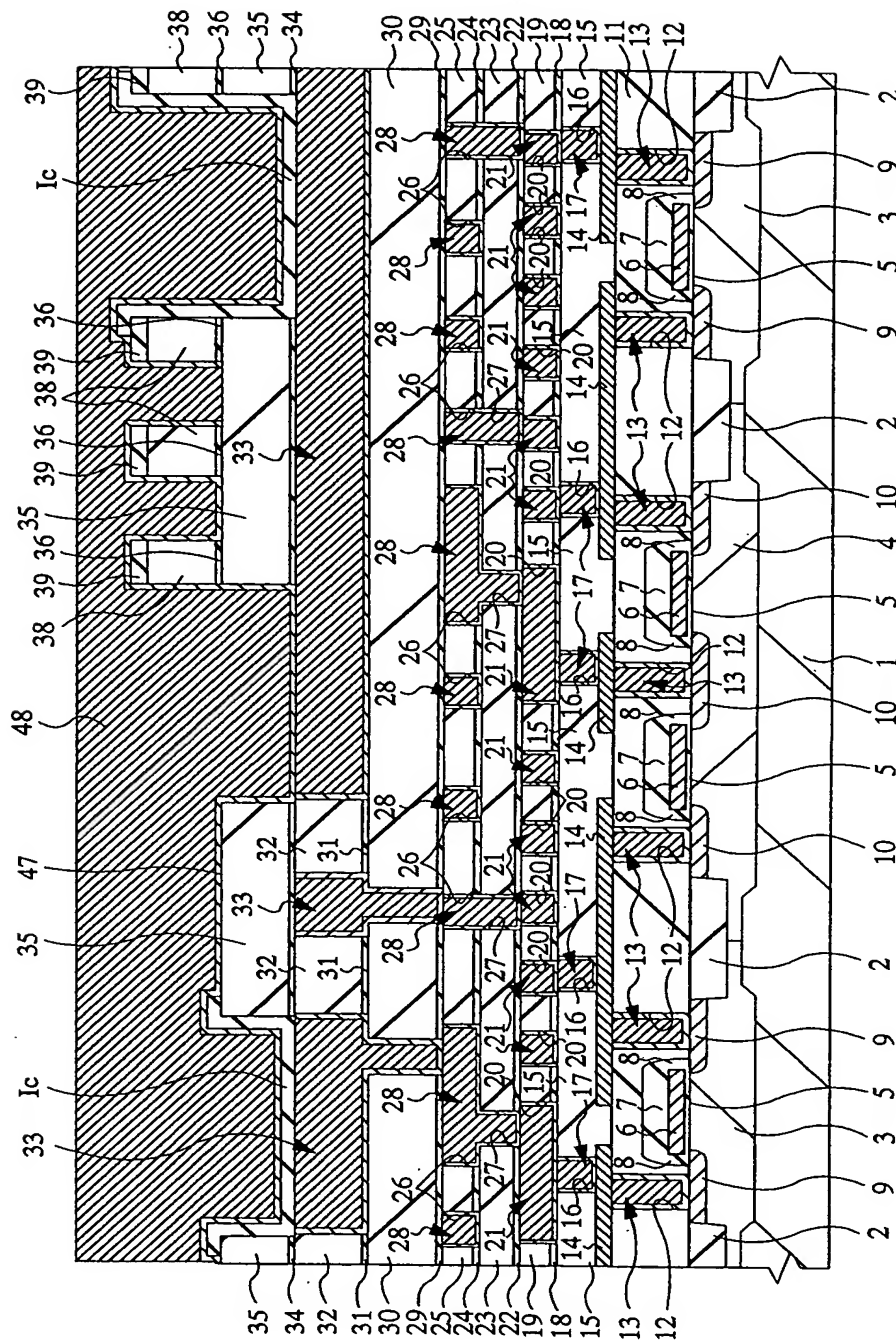


Fig. 20

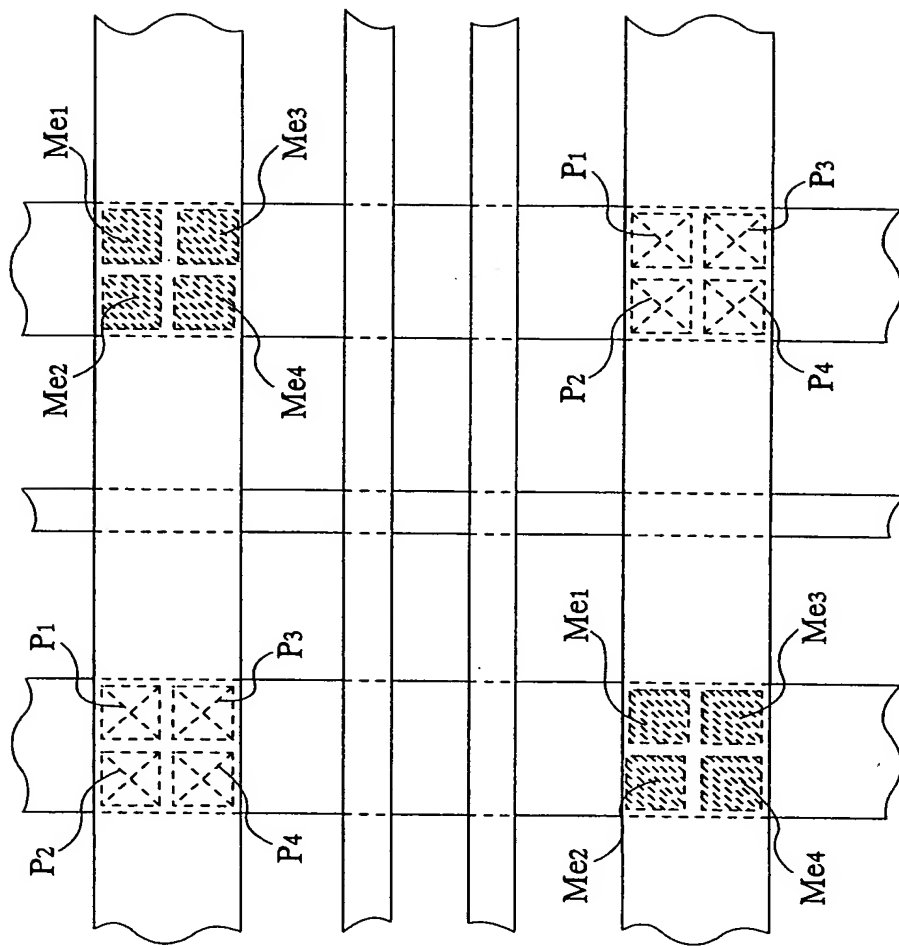


Fig. 21

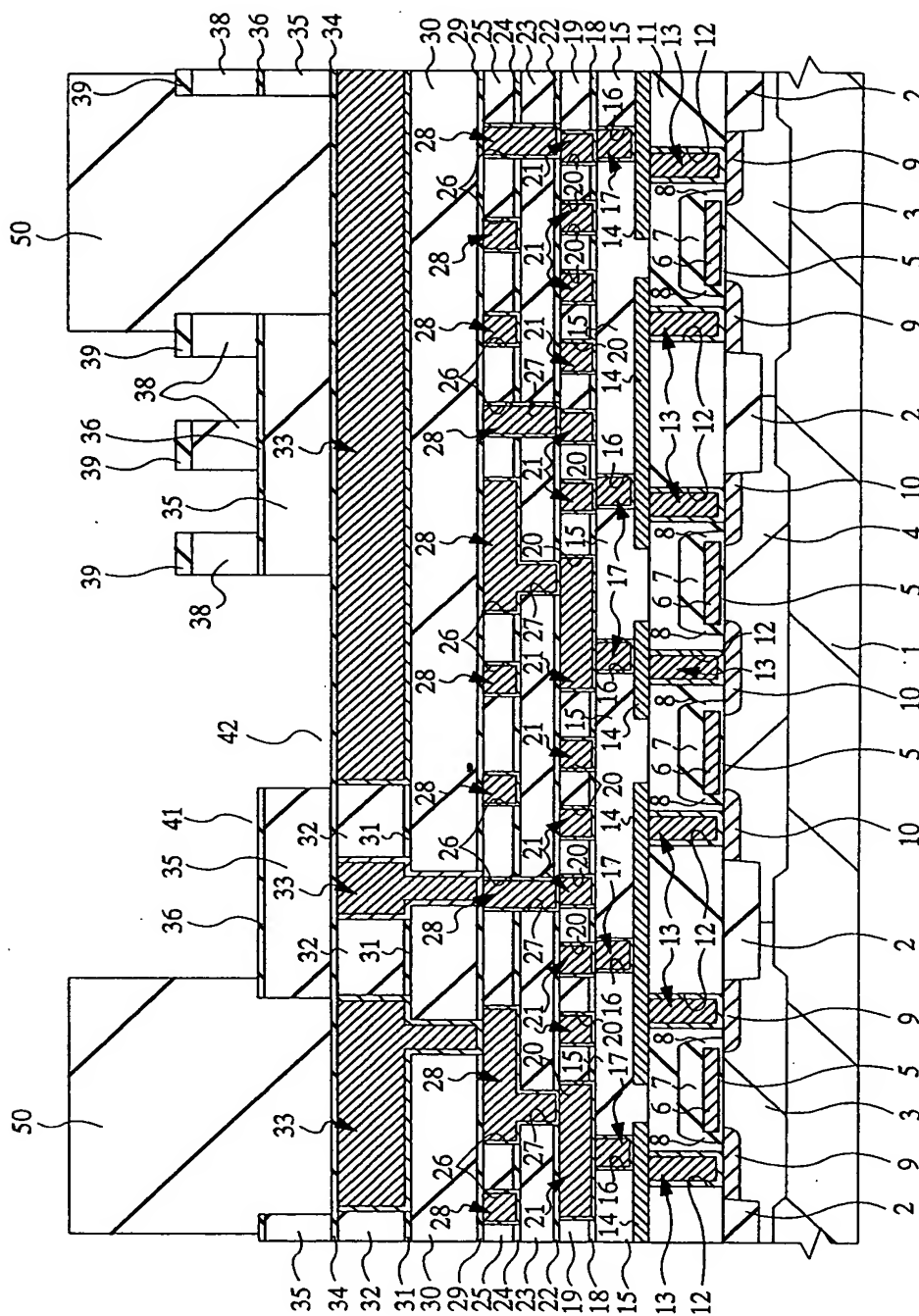


Fig. 22

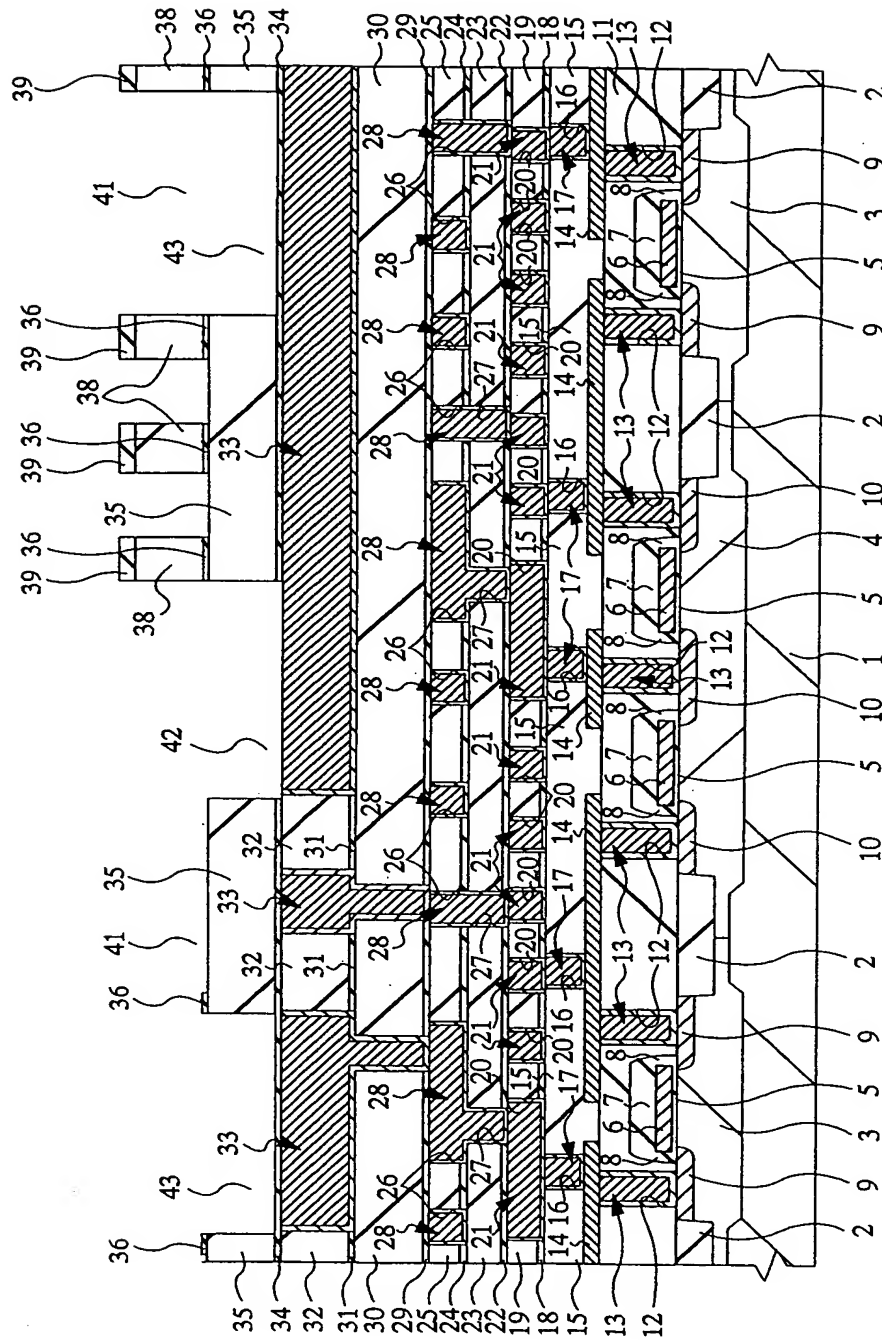


Fig. 23

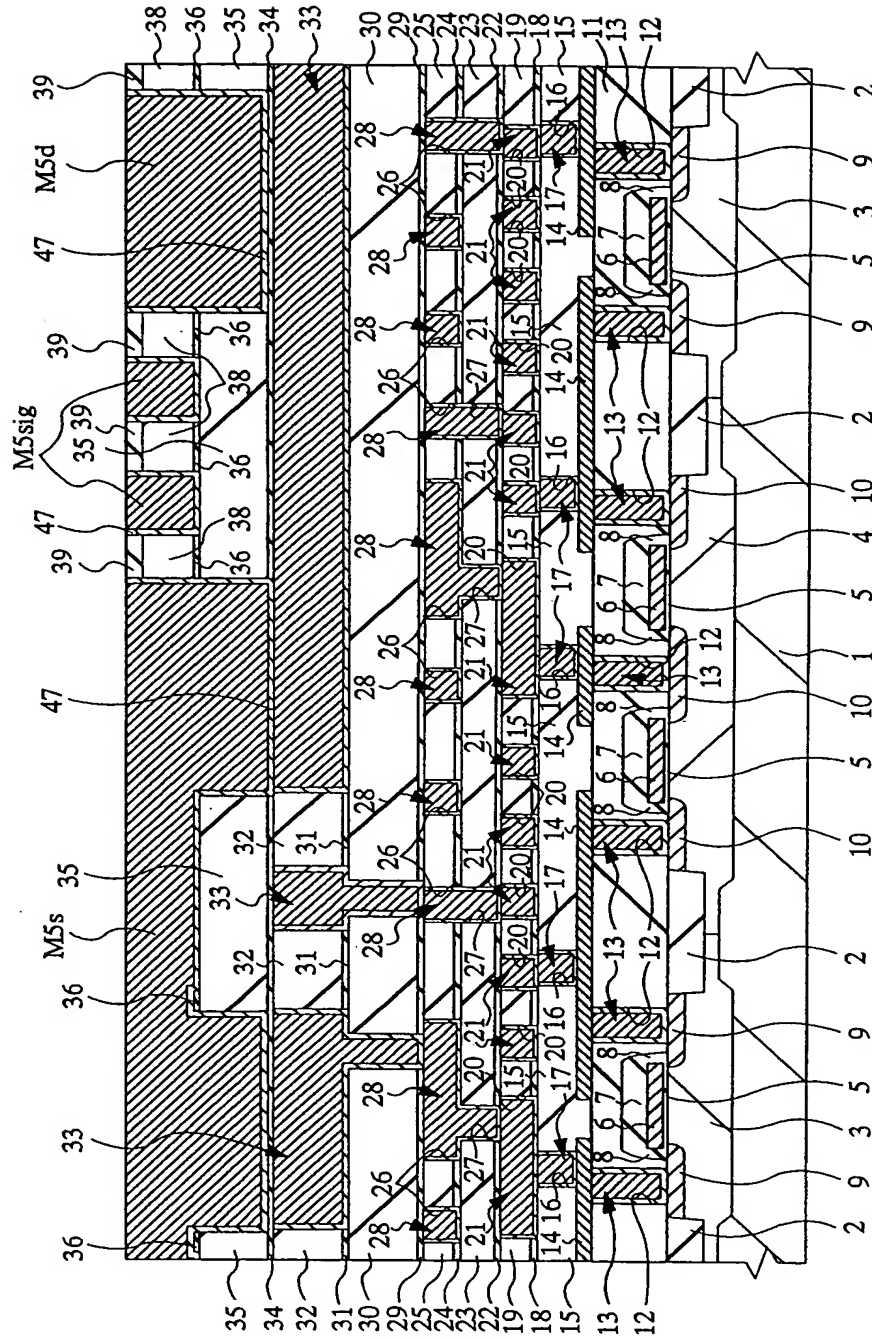


Fig. 24

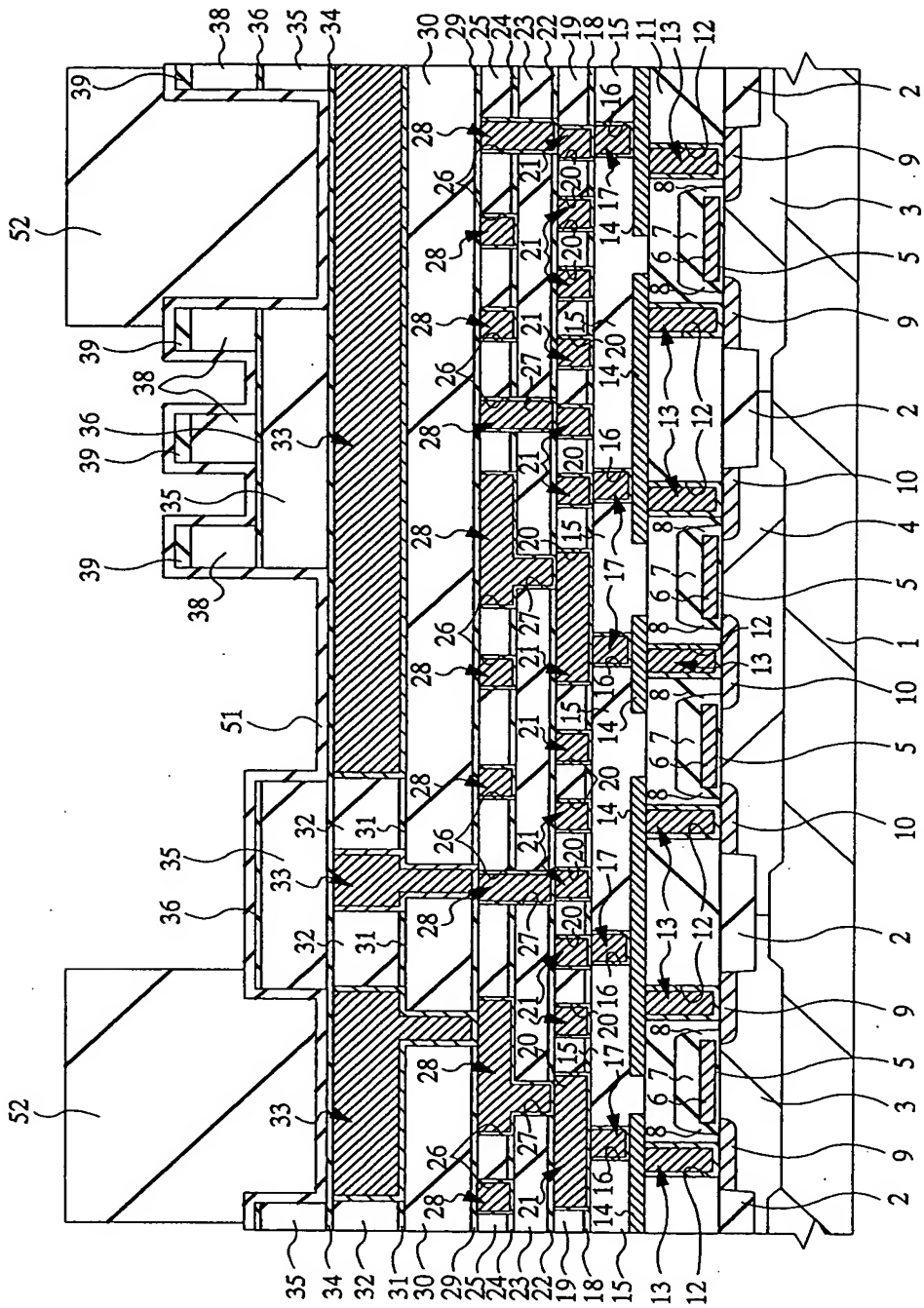


Fig. 26

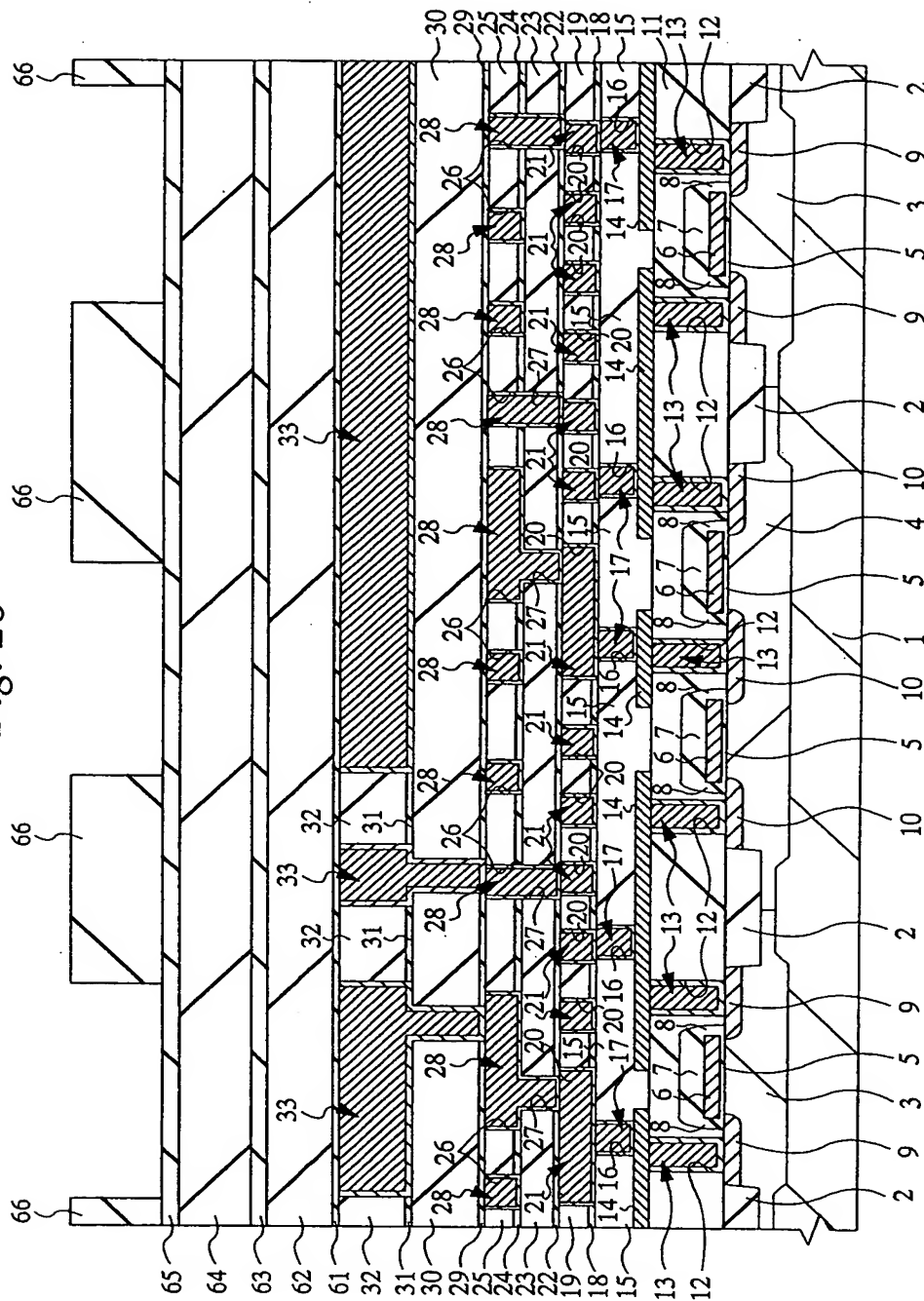


Fig. 27

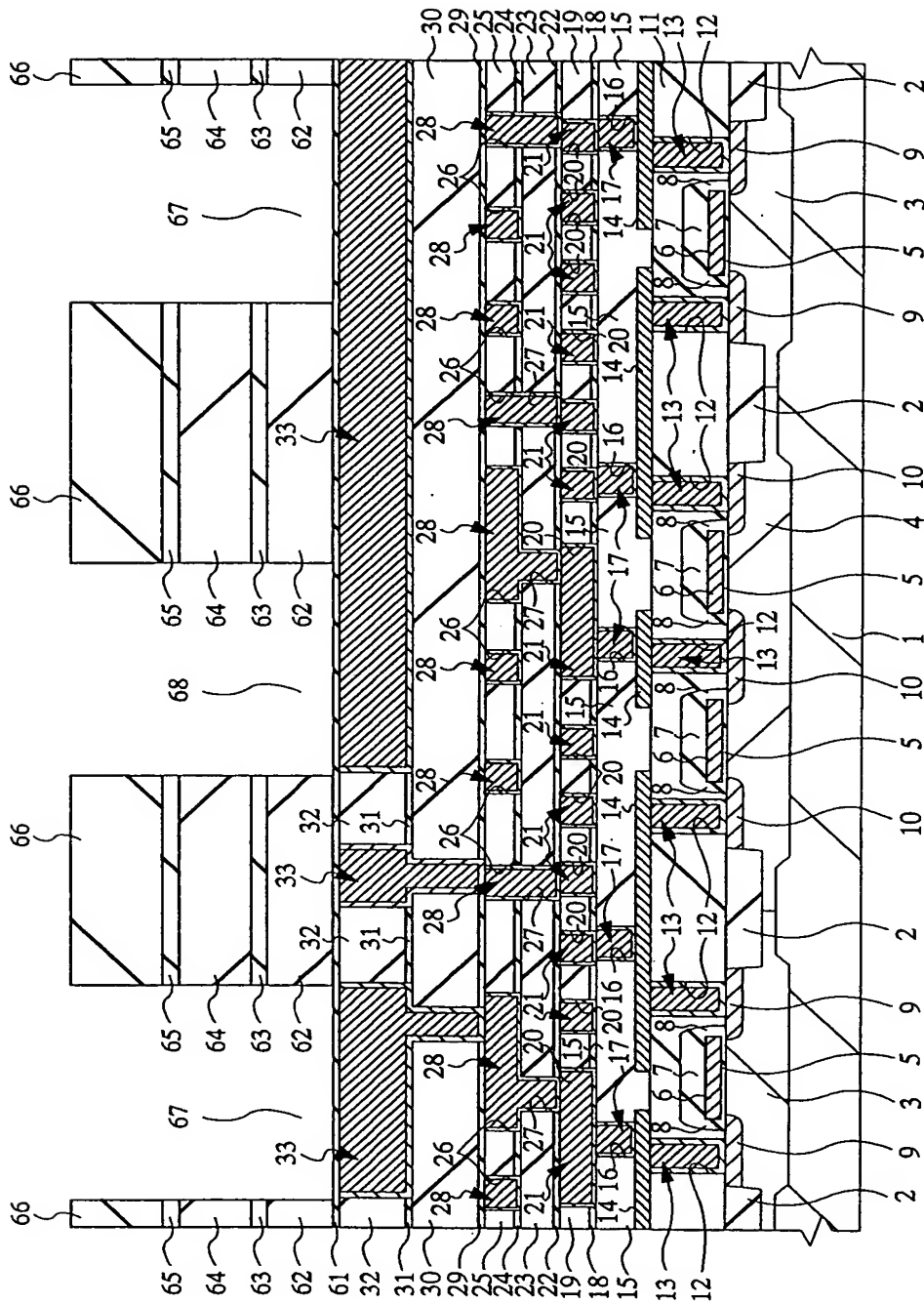


Fig. 28

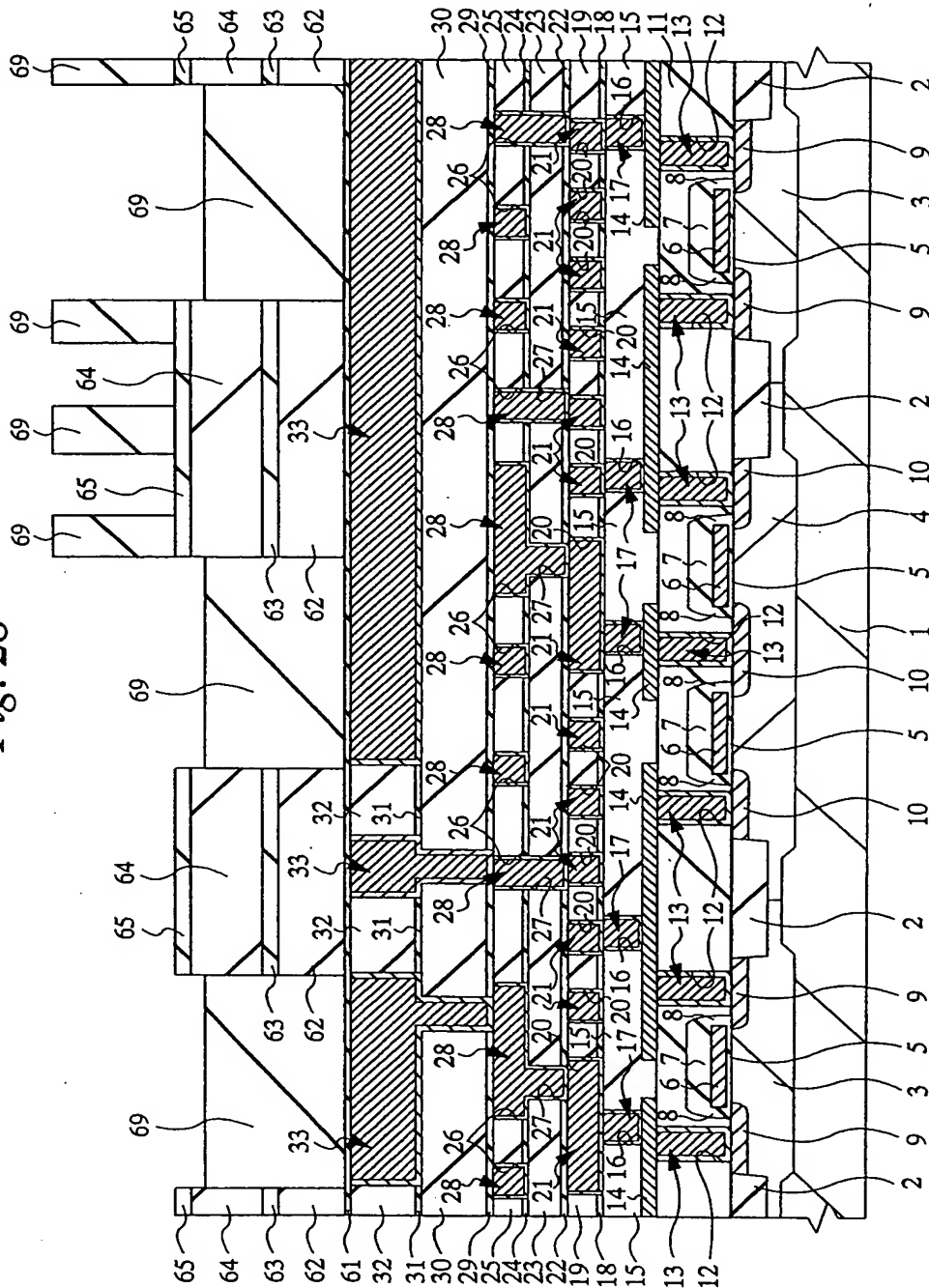


Fig. 29

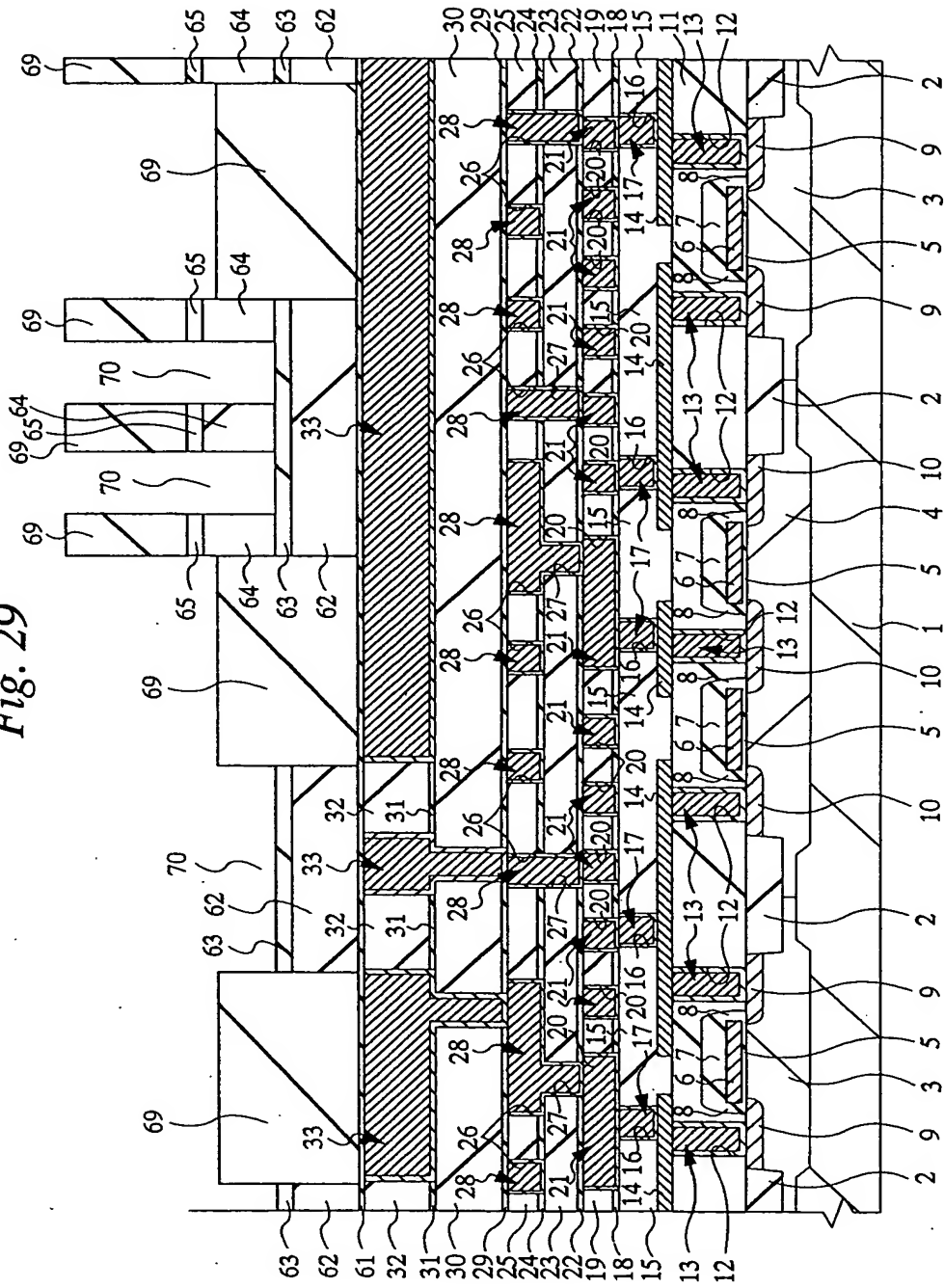


Fig. 30

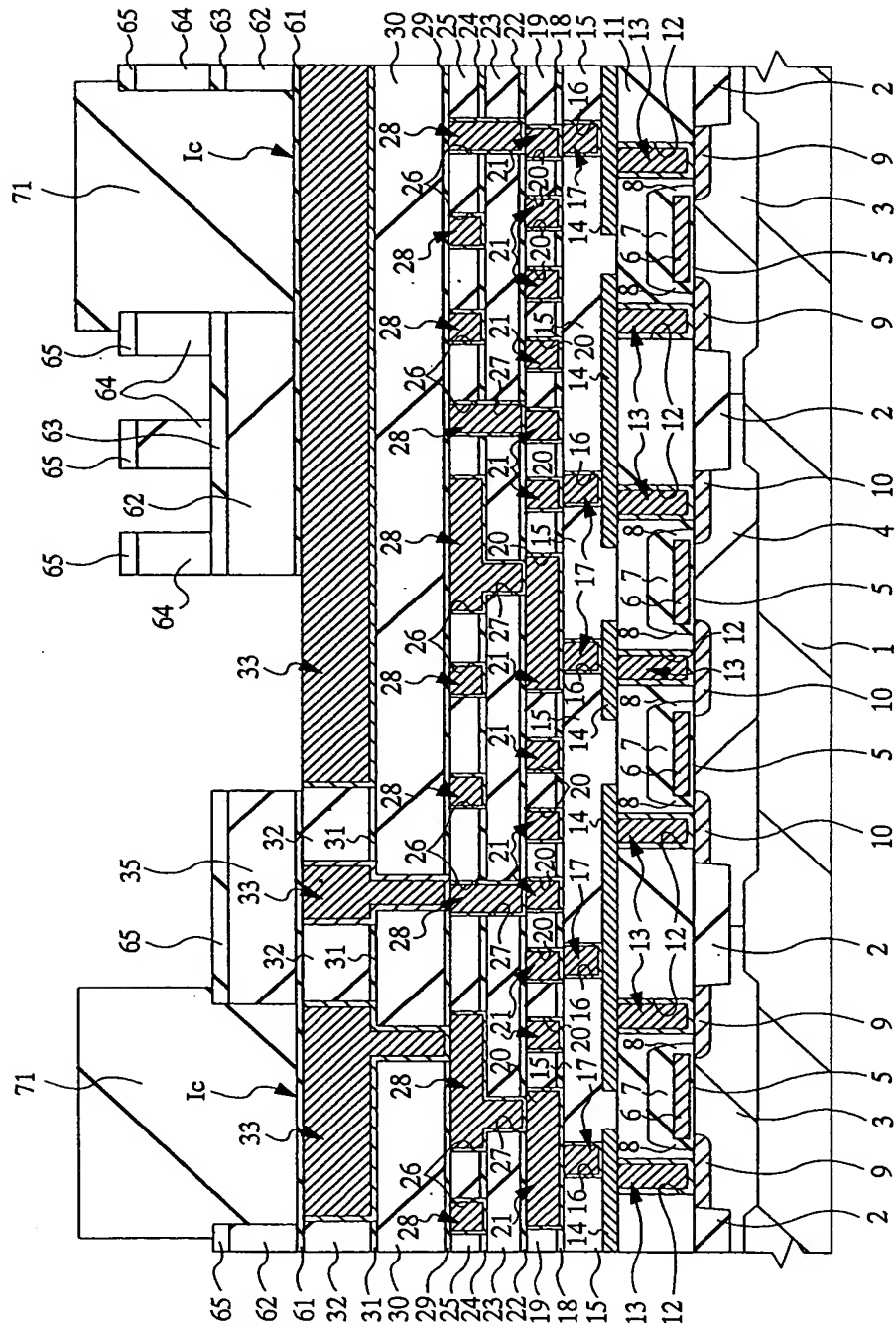


Fig. 31A

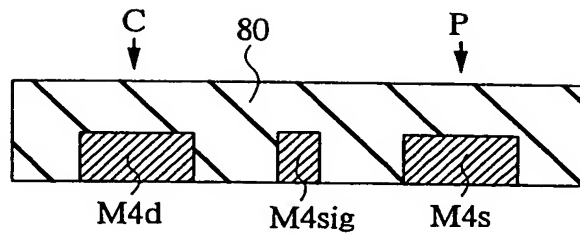


Fig. 31B

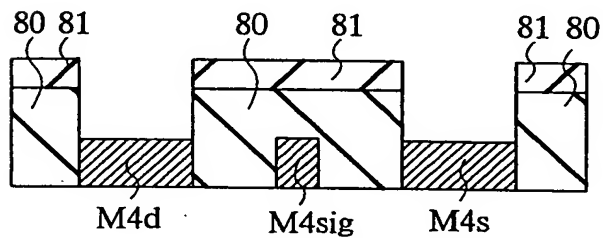


Fig. 31C

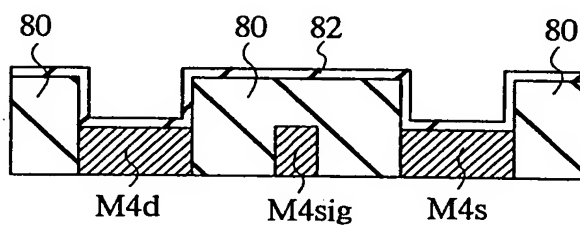


Fig. 31D

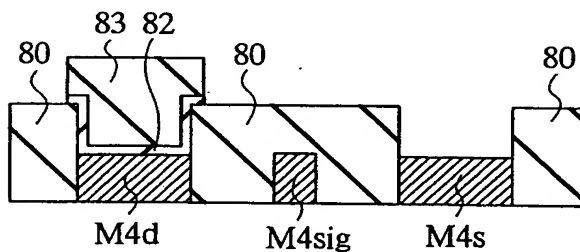


Fig. 31E

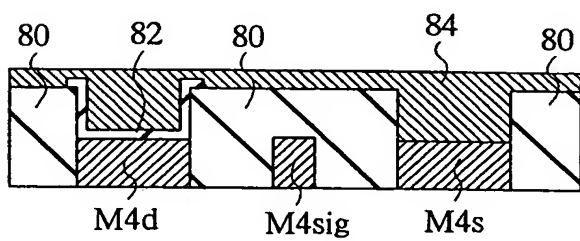


Fig. 32F

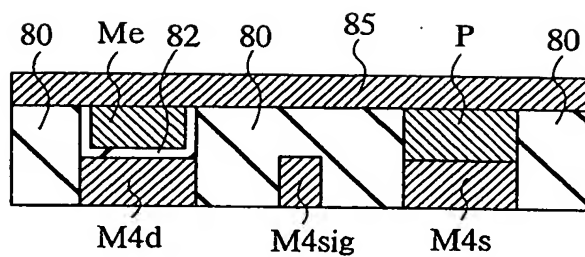


Fig. 32G

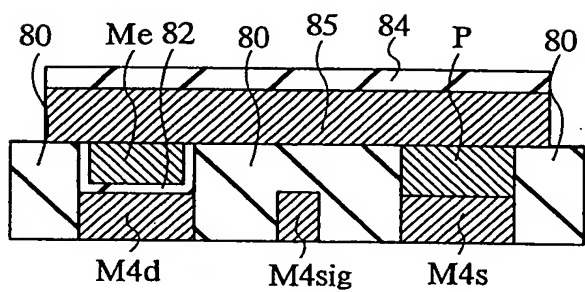


Fig. 32H

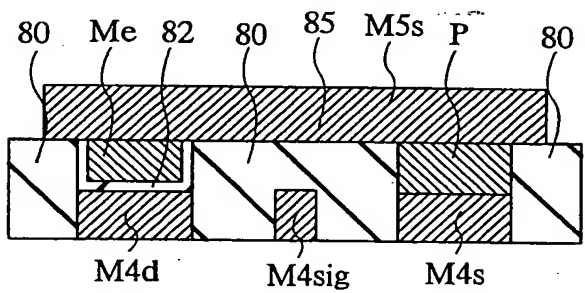


Fig. 33A

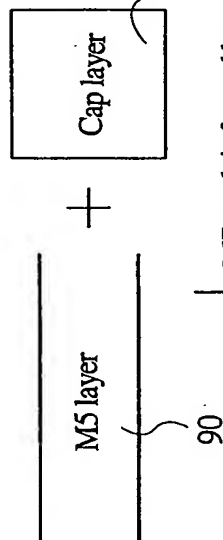
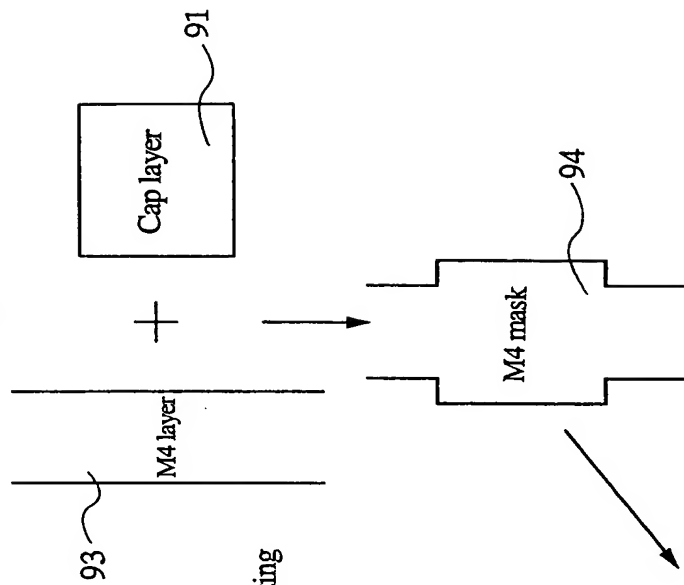


Fig. 33B



M7 mask is formed by synthesizing
M7 layer with cap layer.

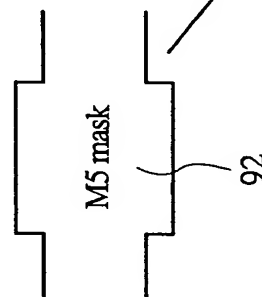


Fig. 33C

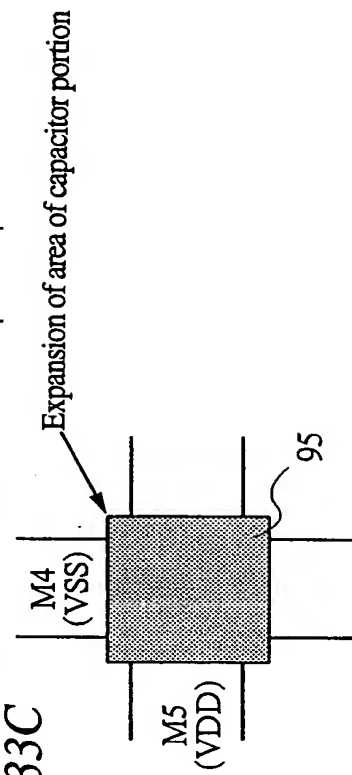


Fig. 34A

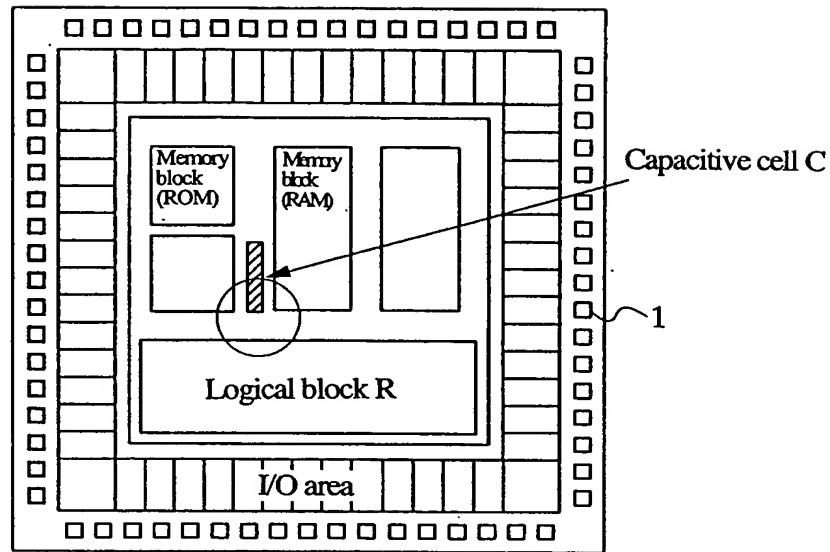


Fig. 34B

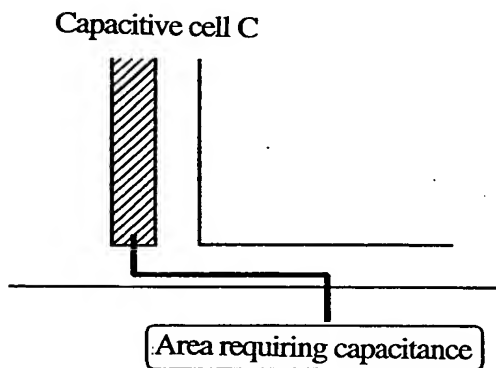


Fig. 34C

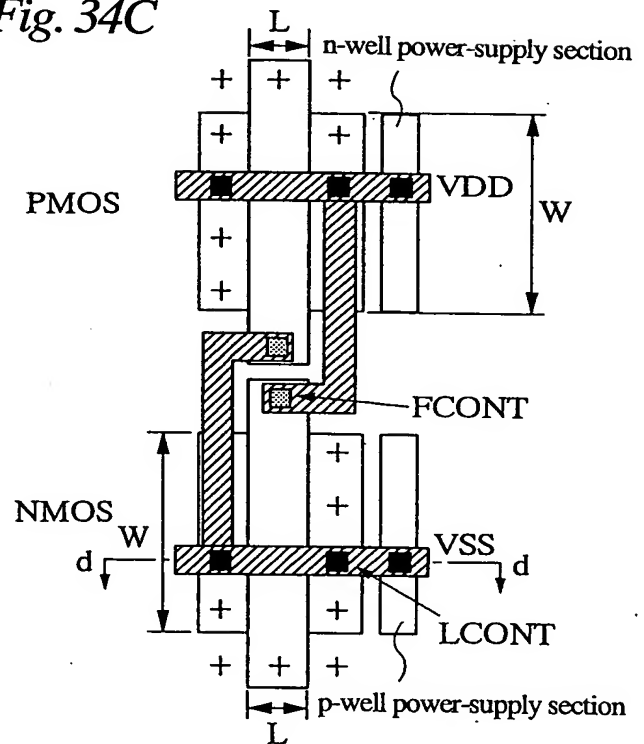


Fig. 34D

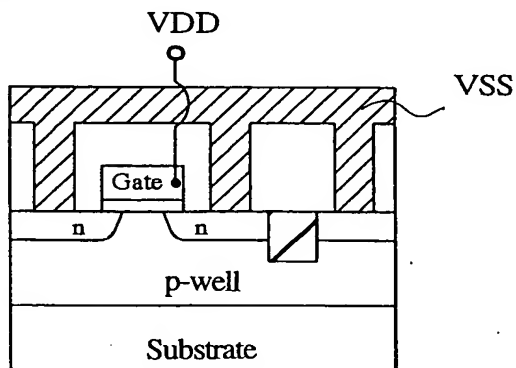


Fig. 35A

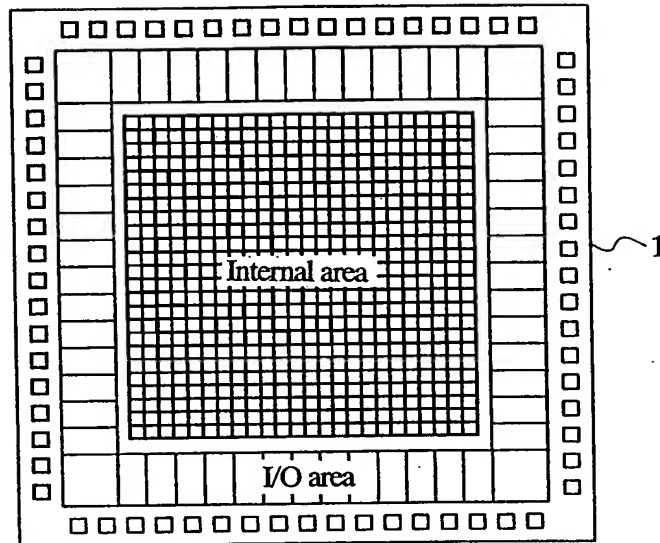


Fig. 35B

